QUERY CONTR	OL FORM	RTIS USE ONLY			
Application No.	10/777.071	Prepared by	e w c	Tracking Number	05966851
Examiner-GAU	Mulpori	Date	8/23/04	Week Date	6-14-04
	2812	No. of queries	- 1-	IFW	

JACKET					
a. Serial No.	f. Foreign Priority	k. Print Claim(s)	p. PTO-1449		
b. Applicant(s)	g. Disclaimer	I. Print Fig.	q. PTOL-85b		
c. Continuing Data	h. Microfiche Appendix	m. Searched Column	r. Abstract		
d. PCT	i. Title	n. PTO-270/328	s. Sheets/Figs		
e. Domestic Priority	j. Claims Allowed	o. PTO-892	t. Other		

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i. Appendix	
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	initials

Art Unit: 2812

In claim 12, line 5 replace "a" with the

In claim 12, line 40 replace "a" with the

In claim 13, line 6 replace "a" with the

In claim 14, line 9 replace "a" with the

In claim 14, line 11 add the wherein the semiconductor material

In claim 14, line 12 replace "a" with the

In claim 15, line 10 replace "a" with the

In claim 15, line 10 delete "on a plate member disposed"

In claim 15, line 16 after "film" add the wherein the semiconductor film

In claim 15, line 16 after "film" add the wherein the semiconductor film

In claim 15, line 17 replace "a" with the

The following is an examiner's statement of reasons for allowance: Prior art neither teach nor suggest forming layered film with first second and third compound semiconductor layers, wherein second compound layer comprises Al-containing material (as recited in claim 1, 10) or first cladding layer active layer and second cladding layer and at least first cladding layer comprises Al-containing material (as recited in claim 10 and 15), selectively etching layered film and to form three-dimensional structure or stripe having sidewall portion in which Al-containing material is exposed to at least part of the side wall portion, placing three-dimensional or stripe

In claim15, line 17 after "substrate" add --, and--

In claim 15, line 18 replace "a" with -the--